# PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
JIANWEI CHAI	12/21/2017
SHIJIE WANG	12/21/2017
DONGZHI CHI	12/21/2017
MING YANG	12/21/2017

## **RECEIVING PARTY DATA**

Name:	AGENCY FOR SCIENCE, TECHNOLOGY AND RESEARCH	
Street Address:	1 FUSIONOPOLIS WAY	
Internal Address:	#20-10, CONNEXIS NORTH TOWER	
City:	SINGAPORE	
State/Country:	SINGAPORE	
Postal Code:	138632	

# **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	16645512

### **CORRESPONDENCE DATA**

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Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

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Email: docket@marshallip.com

Correspondent Name: MARSHALL, GERSTEIN & BORUN LLP

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ATTORNEY DOCKET NUMBER:	31336/55175
NAME OF SUBMITTER:	CHRISTINE HILLS
SIGNATURE:	/Christine Hills/
DATE SIGNED:	04/13/2020

**Total Attachments: 5** 

PATENT REEL: 052381 FRAME: 0221

506011927



PATENT REEL: 052381 FRAME: 0222

1048/P/10133/00/EG

#### **DEED OF ASSIGNMENT**

THIS DEED made the <u>21</u> of <u>December</u> two thousand and seventeen (2017) BETWEEN.

- 1. CHAI, Jianwei c/o Institute of Materials Research and Engineering 2 Fusionopolis Way, #08-03, Innovis Singapore 138634 Singapore
- 2. WANG, Shijie c/o Institute of Materials Research and Engineering, 2 Fusionopolis Way, #08-03, Innovis Singapore 138634 Singapore
- 3. CHI, Dongzhi
  c/o Institute of Materials Research and Engineering,
  2 Fusionopolis Way, #08-03, Innovis
  Singapore 138634
  Singapore
- 4. YANG, Ming c/o Institute of Materials Research and Engineering 2 Fusionopolis Way, #08-03, Innovis Singapore 138634 Singapore

[hereinafter referred to as "the Assignors"]

<u>AND</u>

Agency for Science, Technology and Research

1 Fusionopolis Way,

#20-10 Connexis North Tower

Singapore 138632

Singapore

[hereinafter referred to as "the Assignee"]

<u>WHEREAS</u> the Assignors warrant that the Assignors are the first and true inventors of an invention entitled "A Novel Sputtering System With Central Electrode And

Hollow Sputtering Cathode For 2D Film Deposition" [hereinafter referred to as

"the Invention"], the subject of Singapore Application No.10201707414P, filed at the

Intellectual Property Office of Singapore [hereinafter referred to as "the Application"]

AND WHEREAS the Assignors have agreed to assign to the Assignee and the

Assignee desires to take assignment of all rights, title and interest of the Assignors in

and to the Invention and the Application,

NOW THIS DEED WITNESSETH

1. In consideration of the sum of one dollar (\$1) and other good and valuable

consideration receipt of which is hereby acknowledged by the Assignors, the

Assignors hereby assign to the Assignee all of his rights, title and interest in and to

the Invention and the Application including:

(a) all rights and powers to make one or more applications for Letters Patent or

other form of protection in the name of the Assignee in Singapore, the United States of America and in any other country of the world in respect of the

Invention, and all rights, title and interest in and to any Letters Patent or other

form of protection to mature from any such application,

(b) the rights and powers to prosecute the Application and all rights, title and

interest in and to any Patent or Patents granted thereon together with any extension of the term of any such Patent or Patents as may be granted,

SAVE THAT nothing in this Deed shall prevent the filing or proceeding of an

Application to which this Deed relates, in the name of the Assignors or Inventors where such filing or proceeding of such Application is beneficial to the interests of the Assignee

- (c) the rights and powers to seek protection in countries other than Singapore by way of Patent, Petty Patent, Utility Model, Design Patent or other appropriate form of protection for the Invention, by way of application(s) for such protection made to the appropriate authorities in such other country or countries as the Assignee in its complete discretion may elect, whether or not any such foreign application(s) be made claiming International Convention priority from the Application hereby assigned
- (d) any Copyright owned by the Assignors in and to any drawings relating to the subject matter of the Invention together with the rights and powers such as subsist at the date of this Deed
- (e) to apply for registration of Copyright, Design, Design-Patent or like protection in the name of the Assignee in Singapore and in any other country of the world in respect of the subject matter of the said drawings and to any registration of Copyright, Design-Patent or like protection which matures from any such application, together with the rights to sue in respect of any infringement of that Copyright which may have occurred before the date of this Deed
- 2. The Assignors agree, at the expense of the Assignee, to sign, execute and deliver all documents, forms and papers reasonably required to be produced or obtained by the Assignee in connection with any application for Letters Patent or other form of protection for the subject matter of the Invention, in Singapore or elsewhere.

<u>IN WITNESS WHEREOF</u> the Assignors and Assignee executed this Deed the day and year first hereinbefore written.

# **ASSIGNORS**

SIGNED, SEALED and DELIVERED

By the said

CHAI, Jianwei

in the presence of:

(Witness)

SIGNED, SEALED and DELIVERED

By the said

WANG, Shijie

in the presence of:

(Witness)

SIGNED, SEALED and DELIVERED

By the said

CHI, Dongzhi

in the presence of:

SIGNED, SEALED and DELIVERED

By the said

YANG, Ming

in the presence of:

(Witness)

**ASSIGNEE** 

FOR AND ON BEHALF OF

By the said

Agency for Science, Technology and

Research

in the presence of:

Kahwichin

(Witness) CECILIA FOH

AGRESAN SACHI
GENERAL COUNSEL
AGREST TOS SCIENCE, TECHNOLOSY AND RESEARCH

(3624928\_1):JCF

PATENT REEL: 052381 FRAME: 0227

**RECORDED: 04/13/2020**